



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

June 18, 2026

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG810617102

LABORATORY GROWN DIAMOND

CUT CORNERED RECTANGULAR
MODIFIED BRILLIANT

9.05 X 6.29 X 4.04 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

2.00 CARATS

G

VS 1

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

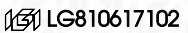
EXCELLENT

EXCELLENT

NONE

Inscription(s)

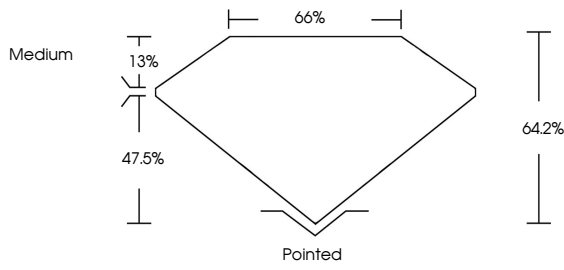
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



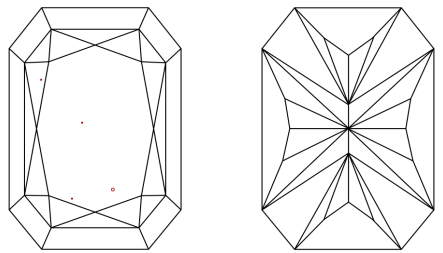
IGI LG810617102

LABORATORY GROWN DIAMOND REPORT

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.



Sample Image Used

COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

FL

IF

VVS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Flawless

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included



© IGI 2020, International Gemological Institute

FD - 10 20

LABORATORY GROWN DIAMOND REPORT



June 18, 2026

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG810617102

LABORATORY GROWN DIAMOND

CUT CORNERED RECTANGULAR MODIFIED BRILLIANT

9.05 X 6.29 X 4.04 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

2.00 CARATS

G

VS 1

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

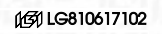
EXCELLENT

EXCELLENT

NONE

Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



IGI LG810617102



June 18, 2026

IGI Report No LG810617102

CUT CORNERED RECT. MODIFIED BRILLIANT

9.05 X 6.29 X 4.04 MM

Carat Weight

Color Grade

Clarity Grade

Depth

Table

Girdle

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

2.00 CARATS

G

VS 1

64.2%

65%

Medium

Pointed

EXCELLENT

EXCELLENT

NONE



Comments: The Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa